Docket No. 245102US2SX DIV

IN RE APPLICATION OF: HIROYUKI KANAYA ET AL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

GAU:

SERIAL NO: NEW DIVISIONAL APP		LICATION	EXAMINER:
FILED:	HEREWITH		
FOR:	SEMICONDUCTOR DE METHOD THEREOF	VICE HAVING FERROELECT	TRIC FILM AND MANUFACTURING
		REQUEST FOR PRIO	RITY
	ONER FOR PATENTS RIA, VIRGINIA 22313		
SIR:			
	efit of the filing date of U.S. ovisions of 35 U.S.C. §120		/178,744, filed June 25, 2002, is claimed pursuant
☐ Full benefit of the filing date(s) of §119(e):		J.S. Provisional Application(s) i Application No.	s claimed pursuant to the provisions of 35 U.S.C. <u>Date Filed</u>
	nts claim any right to priori isions of 35 U.S.C. §119, a		ions to which they may be entitled pursuant to
In the matter	of the above-identified ap	olication for patent, notice is her	eby given that the applicants claim as priority:
COUNTRY		APPLICATION NUMBER	MONTH/DAY/YEAR
□ are so will to were □ were Rece acknowly	ipt of the certified copies bowledged as evidenced by	ent of the Final Fee erial No. filed nal Bureau in PCT Application I y the International Bureau in a ti the attached PCT/IB/304. ere filed in prior application Seri	mely manner under PCT Rule 17.1(a) has been
		I	Respectfully Submitted,
Customer	Number	Ī	DBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C. Charles of the control of the
		1	20510444011 110. 20,070

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